PATENT Customer No. 22,852 Attorney Docket No. 04329.2543-01

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Divisional Application of Serial No. 09/812,688, filed March 21, 2001, of:  Masamitsu ITOH et al.  Application No.: To be Assigned  Filed: Herewith  For: PATTERN FORMATION MATERIAL, PATTERN FORMATION METHOD, AND EXPOSURE MASK FABRICATION METHOD	) : ) Group Art Unit: To be Assigned ) ) Examiner: To be Assigned ) ) ) )
Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450	

## PRELIMINARY AMENDMENT

Prior to the examination of the above application, please amend this application as follows:

Amendments to the Specification begins on page 2.

Amendments to the Claims are reflected in the listing of claims beginning on page 3.

Remarks follow the amendment sections of this paper.

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